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Docket Number (Optional)

TSMC-01-132

Application Number:

10/040,042

Applicant:

Wei-Yu Su

FBIHQ Denver

11/07/01

Group Art Unit

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

EL-Arini

DATE CONSIDERED

3/1/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.